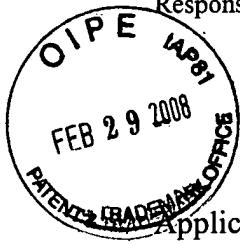


03-03-08

ITW

U.S. Application No. 10/752,642
Response to Non-Final Office Action dated 11/30/2007

PATENT
790001-2042



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Naofumi NAKAMURA et al.
Serial No. : 10/752,642
For : SEMICONDUCTOR DEVICE AND METHOD OF
FABRICATING THE SAME
Filing Date : January 7, 2004
Examiner : Chris C. Chu
Group Art Unit : 2815
Confirmation No. : 4109

745 Fifth Avenue
New York, NY 10151

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AMENDMENT UNDER 37 C.F.R. §1.121

M.S. AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In Response to the Non-Final Office Action mailed on November 30, 2007, having a
three-month statutory period for response set to expire on February 29, 2007, please amend the
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Amendments to the Drawings begin on page 5 of this paper and include an attached replacement sheet.

Remarks/Arguments begin on page 7 of this paper.